

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of:

Confirmation No: 3840

Masaki KOMAKI

Art Unit: 2815

Serial No.: 09/939,752

Examiner: J. Nguyen

Filed: August 28, 2001

Docket No.: 024016-00014

For: FUNDAMENTAL CELL, SEMICONDUCTOR INTEGRATED
DEVICE, WIRING METHOD AND WIRING APPARATUS

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 5, 2004

Sir:

Prior to examining the present application pursuant to the attached RCE in response to the outstanding Office Action dated October 15, 2003, (hereinafter "outstanding Action"), with the response time falling within the shortened statutory period, please amend the application in a manner as shown below.

RECEIVED

JAN - 8 2004

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